

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L22	496	(SiCN or SiNC or (Si?sub\$6 near3 N?sub\$3 near3 C?sub\$3)) and (etch\$6 near5 (higher or lower or high or low or different\$6))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 16:21
L23	131	22 and (@ad<"20000119" or @rlad<"20000119")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 16:23

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L20	336	(SiCN or SiNC or (Si?sub\$6 near3 N?sub\$3 near3 C?sub\$3)) and (etch\$6 near5 selectiv\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 16:14
L21	44	20 and (@ad<"20000119" or @rlad<"20000119")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 16:15

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L3	9074	((N or nitrogen) near5 (carbide or SiC))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 15:58
L17	181147	(C or carbon) near5 (oxide or SiO <sub>2</sub> or SiO <sub>2</sub> or ((Si or silicon) adj (oxide or dioxide)))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 16:04
L18	135	3 and 17 and (selectiv\$6 near10 etch\$6)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 16:05
L19	27	18 and (@ad<"20000119" or @rlad<"20000119")	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2006/02/13 16:05



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Edit an existing query or  
compose a new query in the  
Search Query Display.

**Search Query Display**


Select a search number (#)  
to:

- Add a query to the Search Query Display
- Combine search queries using AND, OR, or NOT
- Delete a search
- Run a search

 
**Recent Search Queries**

- #1** (( ( same, similar, identical, equak<in>metadata ) <and> ( dielectric constant, permittiv\*<in>metadata ) )<and> ( etch\*<in>metadata ) ) <and> (pyr >= 1950 <and> pyr <= 2000)
- #2** (( ( selectiv\*<in>metadata ) <and> ( etch\*<in>metadata ) )<and> ( siocn, sic, dielectric, insulat\*, sic, carbide <in>metadata ) ) <and> (pyr >= 1950 <and> pyr <= 2000)
- #3** ((( ( same, similar, identical, equak<in>metadata ) <and> ( dielectric constant, permittiv\*<in>metadata ) )<and> ( etch\*<in>metadata ) ) <and> (pyr >= 1950 <and> pyr <= 2000)) <AND> ((( ( selectiv\*<in>metadata ) <and> ( etch\*<in>metadata ) )<and> ( siocn, sic, dielectric, insulat\*, sic, carbide <in>metadata ) ) <and> (pyr >= 1950 <and> pyr <= 2000))

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